

# Cypress Semiconductor Product Qualification Report

QTP# 002104 VERSION 2.0  
October, 2003

<b>EnCoRe™ USB</b>	
<b>P26TLM Technology, Fab 2-CTI</b>	
<b>CY7C63221A/ CY7C63231A</b>	<b>Low Speed USB Peripheral Controller</b>

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## CYPRESS TECHNICAL CONTACT FOR QUALIFICATION DATA:

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### PRODUCT QUALIFICATION HISTORY

<b>Qual Report</b>	<b>Description of Qualification Purpose</b>	<b>Date Comp</b>
99273	New P26 with TML Technology Qualification	Oct 99
002104	New CY7C63221A/31A USB product Qualification, P26 with TML Technology	Apr 00

<b>PRODUCT DESCRIPTION (for qualification)</b>	
Qualification Purpose: To qualify CY7C63221A/31A in qualified P26TLM Technology, Fab 2..	
Marketing Part #:	CY7C63221A/CY7C63231A
Device Description:	3.3V, Commercial, available in 16-lead PDIP and 18-lead PDIP/SOIC Package.
Cypress Division:	Cypress Semiconductor Corporation – Interface Product Division (IPD)
Overall Die (or Mask) REV:	Rev. A
What ID markings on Die:	7C6320A

<b>TECHNOLOGY/FAB PROCESS DESCRIPTION</b>			
Number of Metal Layers:	3	Metal Composition:	Metal 1: 6000Å Al, 1200 Å TiW Metal 2: 1500Å TiW, 9000Å Al, 320Å TiW Metal 3: 320 ÅTiW/10000 ÅAl/1500Å TiW
Generic Process Technology/Design Rule (μ-drawn):	Triple Metal / 0.65μm		
Gate Oxide Material/Thickness (MOS):	SiO <sub>2</sub> / 65 Å		
Name/Location of Die Fab (prime) Facility:	Cypress Semiconductor - Round Rock, TX (Fab2)		
Die Fab Line ID/Wafer Process ID:	Fab 2/ P26TLM		

**PACKAGE AVAILABILITY**

<b>PACKAGE TYPE</b>	<b>ASSEMBLY SITE FACILITY</b>
<b>18-lead SOIC</b>	<b>PHIL-M</b>
<b>16/18-lead PDIP</b>	<b>INDNS-O / ALPHA-X</b>

**Note:** Package Qualification details upon request

<b>MAJOR PACKAGE INFORMATION USED IN THIS QUALIFICATION</b>	
<b>Package Designation:</b>	P183A
<b>Package Outline, Type, or Name:</b>	18-lead, Plastic Dual-In Line Package (PDIP)
<b>Mold Compound Name/Manufacturer:</b>	Sumitomo EME-6300
<b>Mold Compound Flammability Rating:</b>	V-O per UL 94
<b>Oxygen Rating Index:</b>	>28%
<b>Lead Frame Designation:</b>	P
<b>Lead Frame Material:</b>	Copper
<b>Lead Finish, Composition / Thickness:</b>	Solder Plated, 85%Sn, 15%Pb
<b>Die Backside Preparation Method/Metallization:</b>	N/A
<b>Die Separation Method:</b>	Wafer Saw
<b>Die Attach Supplier:</b>	Ablestik
<b>Die Attach Material:</b>	Ablestik 8361
<b>Bond Diagram Designation</b>	10-03825
<b>Wire Bond Method:</b>	Thermosonic
<b>Wire Material/Size:</b>	Au, 1.0um
<b>Thermal Resistance Theta JA °C/W:</b>	80
<b>Package Cross Section Yes/No:</b>	N/A
<b>Assembly Process Flow:</b>	49-70027M
<b>Name/Location of Assembly (prime) facility:</b>	OMEDATA (INDNS-O)

<b>ELECTRICAL TEST / FINISH DESCRIPTION</b>	
<b>Test Location:</b>	OMEDATA (INDNS-O)
<b>Fault Coverage:</b>	100%

**RELIABILITY TESTS PERFORMED PER SPECIFICATION REQUIREMENTS**

<b>Stress/Test</b>	<b>Test Condition (Temp/Bias)</b>	<b>Result P/F</b>
High Temperature Operating Life Early Failure Rate	Dynamic Operating Condition, Vcc = 5.75V, 150°C	P
High Temperature Operating Life Latent Failure Rate	Dynamic Operating Condition, Vcc = 5.75V, 150°C	P
Extended Dynamic Burn-in	Dynamic Operating Condition, Vcc = 5.75V, 150°C	P
High Accelerated Saturation Test (HAST)	130°C/140%/5.5V, 85%RH Precondition: JESD22 Moisture Sensitivity Level 1 168 Hrs, 85°C/85%RH+3IR-Reflow, 220°C+5, -0°C	P
Temperature Cycle	MIL-STD-883C, Method 1010, Condition C, -65°C to 150°C Precondition: JESD22 Moisture Sensitivity Level 1 168 hrs, 85°C/85%RH+3IR-Reflow, 220°C+5, -0°C	P
Electrostatic Discharge Human Body Model (ESD-HBM)	MIL-STD-883, Method 3015.7 (2,200V)	P
Electrostatic Discharge Charge Device Model (ESD-CDM)	Cypress Spec. 25-00020 (1,000V)	P
High Temperature Storage	16°C, No Bias	P
Static Latchup Sensitivity	In accordance with JEDEC 17. Cypress Spec. 01-00081 ( $\pm$ 300mA)	P
Pressure Cooker	Cypress Spec. 25-00047, 121°C/100%RH Precondition: JESD22 Moisture Sensitivity Level 1 168 hrs, 85°C/85%RH+3IR-Reflow, 220°C+5, -0°C	P
Age Bond	MIL-STD-883, Method 2011	P
Acoustic Microscopy	Cypress Spec 25-000104	P
SEM	MIL-STD-883, Method 2018-2	P

**RELIABILITY FAILURE RATE SUMMARY**

Stress/Test	Device Tested/ Device Hours	# Fails	Activation Energy	Acceleration Factor <sup>3</sup>	Failure Rate <sup>4</sup>
High Temperature Operating Life Early Failure Rate	4,078	0	N/A	N/A	0 PPM
High Temperature Operating Life <sup>1,2</sup> Long Term Failure Rate	248,100 DHRs	0	0.7	170	22 FIT

<sup>1</sup> Assuming an ambient temperature of 150°C and a junction temperature rise of 15°C.

<sup>2</sup> Chi-squared 60% estimations used to calculate the failure rate.

<sup>3</sup> Thermal Acceleration Factor is calculated from the Arrhenius equation

$$AF = \exp \left[ \frac{E_A}{k} \left[ \frac{1}{T_2} - \frac{1}{T_1} \right] \right]$$

where:

$E_A$  =The Activation Energy of the defect mechanism.

$k$  = Boltzmann's constant =  $8.62 \times 10^{-5}$  eV/Kelvin.

$T_1$  is the junction temperature of the device under stress and  $T_2$  is the junction temperature of the device at use conditions.

<sup>4</sup> EFR and LFR based on QTP 99273 and 002104

## Reliability Test Data

QTP #: 002104

<i>Device</i>	<i>Fab Lot #</i>	<i>Assy Lot #</i>	<i>Assy Loc</i>	<i>Duration</i>	<i>Samp</i>	<i>Rej</i>	<i>Failure Mechanism</i>
<b>STRESS: HIGH TEMP DYNAMIC OPERTING LIFE - EARLY FAILURE RATE (150C, 5.75V, VCC MAX)</b>							
CY7C63231A-PC	2031881	510010227/8	INDNS-O	48	497	0	
CY7C63231A-PC	2031881	510010227/8	INDNS-O	48	503	0	
<b>STRESS: HIGH TEMP DYNAMIC OPERTING LIFE-LATENT FAILURE RATE (150C, 5.75V, Vcc Max)</b>							
CY7C63231A-PC	2031881	510010227/8	INDNS-O	80	117	0	
CY7C63231A-PC	2031881	510010227/8	INDNS-O	500	117	0	
<b>STRESS: PRESSURE COOKER TEST (121C, 100%RH)</b>							
CY7C63231A-PC	2031881	510010227/8	INDNS-O	168	46	0	
<b>STRESS: STATIC LATCH-UP TESTING (125C, 11.5V, +/-300mA)</b>							
CY7C63231A-PC	2031881	510010227/8	INDNS-O	COMP	3	0	

**RELIABILITY TEST DATA**

**QTP#: 99273**

DEVICE	ASSY-LOC	FABLOT#	ASSYLOT#	DURATION	S/S	REJ	FAIL MODE
STRESS: HIGH TEMPERATURE STORAGE -PLASTIC (165C, NO BIAS)							
7C6399AT	CSPI-R	2920309	619918583	168	78	0	
7C6399AT	CSPI-R	2920309	619918583	552	78	0	
7C6399AT	CSPI-R	2931408	619927766	168	81	0	
7C6399AT	CSPI-R	2931408	619927766	552	81	0	
STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-EARLY FAILURE RATE (150C, 5.75V)							
7C6399AT	INDNS-O	2920309	519911818/19/20	48HRS	978	0	
7C6399AT	CSPI-R	2931408	519915664/5756/	48	1000	0	
7C6399AT	CSPI-R	2920309	619918583	48	1100	0	
STRESS: ESD-CHARGE DEVICE MODEL (1000V)							
7C6399AT	CSPI-R	2920309	619918583	COMP	3	0	
STRESS: ESD-HUMAN BODY CIRCUIT PER MIL STD 883, METHOD 3015 (2200V)							
7C6399AT	CSPI-R	2920309	619918583	COMP	3	0	
STRESS: HI-ACCEL SATURATION TEST (140C/85%RH/5.5V), PRECOND. 168 HRS 85C/85%RH							
7C6399AT	CSPI-R	2920309	619918583	128	50	0	
7C6399AT	CSPI-R	2931408	619927766	128	49	0	
STRESS: HIGH TEMPERATURE STORAGE (165C, NO BIAS)							
7C6399AT	CSPI-R	2920309	619918583	336	46	0	
STRESS: HIGH TEMP DYNAMIC OPERATING LIFE-LATENT FAILURE RATE (150C, 5.75V)							
7C6399AT	INDNS-O	2920309	519911818/19/20	80	120	0	
7C6399AT	INDNS-O	2920309	519911818/19/20	500	120	0	
7C6399AT	CSPI-R	2931408	519915664/5756/	80	120	0	
STRESS: EXTENDED DYNAMIC BURN-IN (150C, 5.75V)							
7C6399AT	CSPI-R	2920309	619918583	1000	120	0	
STRESS: PRESSURE COOKER TEST (121C, 100%RH)							
7C6399AT	CSPI-R	2920309	619918583	168	47	0	
STRESS: TC COND. C, -65 TO 150C, PRECOND. 168 HRS 85C/85%RH (MSL 1)							
7C6399AT	CSPI-R	2920309	619918583	300	45	0	